

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 3840

Masaki KOMAKI

Art Unit: 2815

Serial No.:

09/939,752

Examiner: J. Nguyen

Filed:

August 28, 2001

Docket No.: 024016-00014

For:

FUNDAMENTAL CELL SEMICONDUCTOR INTGRATED CIRCUIT

DEVICE WIRING METHOD AND WIRING APPARATUS

AMENDMENT COVER SHEET

Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450 US AUGUST CENTER 2800 CS August 21, 2003

Sir:

Transmitted herewith is an Amendment in the above-identified application.

□ Small Entity status is claimed

FEE TRANSMITTAL

	Claims Remaining After Amendment	Highest Number Previously Filed	Present Extra	Rate	Basic Fee
Total Claims	23	22	1	x \$18.00	18.00
Independent Claims	6	6	0	x \$84.00	
Multiple Dependent Claims \$280.00					
Reduction by 1/2 for small en	tity				
TOTAL					18.00

KECEIVEL